



UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450
www.uspto.gov

JOHN E. GUNTHER
RAYTHEON COMPANY
P.O. BOX 902 (E1/E150)
EL SEGUNDO CA 90245-0902

Paper No 07102007
MAILED FROM
DIRECTORS OFFICE
JUL 11 2007
TECHNOLOGY CENTER 2800

In re Application of
Robin Reeder et. al
Application No.: 10/720328
Filed: November 24, 2003
For: **SLAB LASER AND METHOD WITH IMPROVED AND
DIRECTIONALLY HOMOGENIZED BEAM QUALITY**

WITHDRAWAL FROM ISSUE
37 CFR 1.313

The purpose of this communication is to inform you that the above-identified application is being withdrawn from issue pursuant to 37 CFR 1.313.

The application is being withdrawn from issue because of unpatentability of at least one claim.

The US Patent and Trademark Office records reveal that the issue fee has not been paid. If the issue fee has been submitted, the applicant may request a refund, or may request that the fee be credited to a deposit account. However, applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Fee(s) Due, applicant may request that the previously submitted issue fee be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Fee(s) Due. If the application is abandoned, applicant may request either a refund or a credit to a Deposit Account.

Any question regarding this communication should be directed to Minsun Harvey, Supervisory Patent Examiner, at (571) 272-1835.

The application is being returned to the examiner for consideration of the preliminary amendment and for taking appropriate action.

Robert Oberleitner, Acting Director

Robert Oberleitner, Director
Technology Center 2800
Semiconductors, Electrical and Optical
Systems and Components